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APPLICATION NO.	Fi	LING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/083,481	(02/27/2002	Yuko Iwabuchi	29273/559 5826		
23838	7590	01/07/2003				
KENYON & KENYON				EXAMINER		
1500 K STR WASHING	•	7., SUITE 700 20005		BERMAN, JACK I		
				ART UNIT	PAPER NUMBER	
				2881		
				DATE MAILED: 01/07/2003		

Please find below and/or attached an Office communication concerning this application or proceeding.

į.	Application No.	Applicant(s)	M
	10/083,481	IWABUCHI ET AL.	
Office Action Summary	Examiner	Art Unit	
	Jack I. Berman	2881	
The MAILING DATE of this communication apportunity	ears on the cover sheet with	n the correspondence addre	985
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply If NO period for reply is specified above, the maximum statutory period we Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b). Status	6(a). In no event, however, may a rep within the statutory minimum of thirty ill apply and will expire SIX (6) MONTI cause the application to become ABA	oly be timely filed (30) days will be considered timely. HS from the mailing date of this comm NDONED (35 U.S.C. § 133).	nunication.
1)⊠ Responsive to communication(s) filed on 26 Λ	lovember 2002 .		
2a)⊠ This action is FINAL . 2b)□ Thi	s action is non-final.		
3) Since this application is in condition for allowa closed in accordance with the practice under t	nce except for formal matte Ex parte Quayle, 1935 C.D	ers, prosecution as to the r . 11, 453 O.G. 213.	nerits is
Disposition of Claims			
4)⊠ Claim(s) <u>1-16</u> is/are pending in the application			
4a) Of the above claim(s) is/are withdraw	n from consideration.		
5) Claim(s) is/are allowed.			
6)⊠ Claim(s) <u>1-16</u> is/are rejected.			
7) Claim(s) is/are objected to.			
8) Claim(s) are subject to restriction and/or	election requirement.		
Application Papers			
9) The specification is objected to by the Examiner			
10) The drawing(s) filed on is/are: a) □ accep			
Applicant may not request that any objection to the			
11) The proposed drawing correction filed on		sapproved by the Examiner.	
If approved, corrected drawings are required in rep			
12) ☐ The oath or declaration is objected to by the Exa	aminer.		
Priority under 35 U.S.C. §§ 119 and 120			
13) Acknowledgment is made of a claim for foreign	priority under 35 U.S.C. §	119(a)-(d) or (f).	
a) ☐ All b) ☐ Some * c) ☐ None of:			
1. Certified copies of the priority documents	s have been received.		
2. Certified copies of the priority documents			
3. Copies of the certified copies of the prior application from the International Bur * See the attached detailed Office action for a list of the certified of the copies of the prior application for a list of the certified of the certified copies of the prior application for a list of the certified copies of the prior application for a list of the certified copies of the prior application from the list of the prior application from the prior applicati	eau (PCT Rule 17.2(a)).		age
14) Acknowledgment is made of a claim for domestic			optication)
a) The translation of the foreign language pro			
15) Acknowledgment is made of a claim for domesti			
Attachment(s)	🗂	(DTO 440) D	
 Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948) Information Disclosure Statement(s) (PTO-1449) Paper No(s) 6 	5) Notice of In	ummary (PTO-413) Paper No(s). formal Patent Application (PTO-1	
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The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless –

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-4, 9, 10, 14, and 15 are rejected under 35 U.S.C. 102(b) as anticipated by or, in the alternative, under 35 U.S.C. 103(a) as obvious over Feuerbaum et al. for the reasons explained in the previous Office action.

Claims 5, 6, 11, and 16 are rejected under 35 U.S.C. 103(a) as being unpatentable over Feuerbaum et al. in view of Meisburger et al. for the reasons explained in the previous Office action.

Claims 7 and 12 are rejected under 35 U.S.C. 103(a) as being unpatentable over Feuerbaum et al. in view of Rose et al. for the reasons explained in the previous Office action.

Claims 8 and 13 are rejected under 35 U.S.C. 103(a) as being unpatentable over Feuerbaum et al. in view of Todokoro et al. for the reasons explained in the previous Office action.

Applicant's arguments filed November 26, 2002 have been fully considered but they are not persuasive. Applicant has presented no reason why the electron microscope described by Feuerbaum et al. could not generate an electron beam having a current of at least 100 nA. As was Application/Control Number: 10/083,481

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explained in the previous Office action, Feuerbaum et al. does not specify a beam current for the method and apparatus so it cannot be determined whether or not the patented scanning electron microscope anticipates the current range of at least 100nA claimed in the instant application, but even if it does not, such currents are matters for routine experimentation which would be obvious if not anticipated. According to the Examiner Note 1.b. to form paragraph 7.27, found in section 706.02(m) of the Manual of Patent Examining Procedure, a rejection under 35 U.S.C. 102(b) as anticipated by or, in the alternative, under 35 U.S.C. 103(a) as obvious over a reference is proper "[w]hen the reference discloses all the limitations of a claim except a property or function, and the examiner cannot determine whether or not the reference inherently possesses properties which anticipate or render obvious the claimed invention but has basis for shifting the burden of proof to applicant as in In re Fitzgerald, 619 F.2d 67, 205 USPQ 594 (CCPA 1980). See MPEP § § 2112-2112.02." This is exactly the situation at hand, and Applicant has not met the burden of proving that Feuerbaum et al. does not contemplate an electron beam current of at least 100 nA. Since Feuerbaum et al. places no restrictions on the electron beam current, it would appear to a person having ordinary skill in the art that the teaching that it is advantageous to provide a beam blanking system, which comprises a deflector, at a crossover in the electron beam formed by a convergence lens would be applicable to electron microscopes at all values of electron current. This is especially true since Feuerbaum et al. teaches, at lines 67 in column 1 through 36 in column 2 and lines 32 in column 3 through 52 in column 4, that one of the objectives of the patented invention is to allow the use of higher beam currents in scanning particle microscopes than is possible in the prior art without a reduction in resolution.

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jack I. Berman whose telephone number is (703) 308-4849. The examiner can normally be reached on M-F (8:30-6:00) with every second Friday off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John R. Lee can be reached on (703) 308-4116. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 872-9318 for regular communications and (703) 872-9319 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

Jack I. Berman
Primary Examiner
Art Unit 2881

jb January 6, 2003